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APPLICANTS Hiroshi Watanabe, Tokyo, JAPAN; Tamotsu Mezaki, Tokyo, JAPAN; Shigeru Kido, Kanagawa, JAPAN; Kiyofumi Sakaguchi, Kanagawa, JAPAN;				
** CONTINUING DATA ***** ** FOREIGN APPLICATIONS ***** JAPAN 2002-207405(PAT.) 07/16/2002 JAPAN 2002-357985(PAT.) 12/10/2002 JAPAN 2003-169819(PAT.) 06/13/2003				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/16/2003				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <u>Examiner's Signature</u> <u>Initials</u>		STATE OR COUNTRY JAPAN	SHEETS DRAWING 13	TOTAL CLAIMS 22
INDEPENDENT CLAIMS 4				
ADDRESS 5514				
TITLE Substrate processing method and substrate processing apparatus				
FILING FEE RECEIVED 1000	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	